IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant

Cristina Gomila et al.

Filed

Herewith

For

METHOD AND APPARATUS FOR MODELING

FILM GRAIN PATTERNS IN THE FREQUENCY

DOMAIN

PRELIMINARY AMENDMENT

Commissioner for Patents MAIL STOP PCT P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

In the US national phase application of PCT/US04/010789 filed herewith, please file the following amendments and enter remarks as follows:

Amendments to the Specification begin on page 2 of this paper.

Remarks begin on page 3 of this paper.